High Resolution Ultrasound Transducers and Arrays for Medical Imaging Applications

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Outline

- Introduction
- Fabrication of high frequency piezocomposites and arrays
- Single element transducers
- Process improvements for HFUS arrays
- Array transducers
- Summary, commercial prospects and ongoing work









Introduction

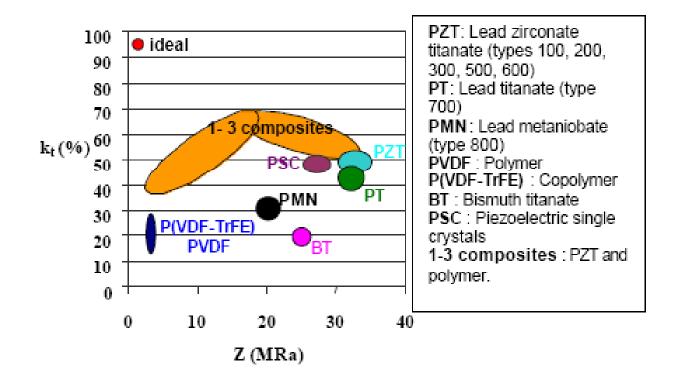








Piezoelectric material selection



- No available material combines a high coupling and a low acoustic impedance
- A good trade off is obtained from 1-3 piezocomposites



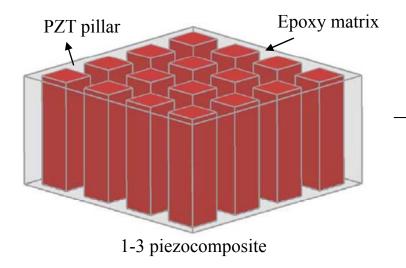


Levassort et al http://www.sea-acustica.es/Sevilla02/ult04010.pdf





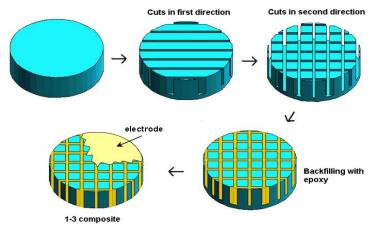
1-3 piezocomposites



Dimension requirements

Frequency	20 MHz	40 MHz
Pillar width	24 µm	14 µm
Kerf	20 µm	8 µm
Thickness	80 µm	40 µm

- Piezocomposites made almost exclusively by the dice-and-fill technique for f<20MHz
- Impossible to fabricate high frequency arrays by dice and fill because of the ultrafine feature size required.



Conventional dice-and-fill technique









High Frequency Ultrasound (HFUS)

- HFUS offers high spatial resolution (< 100 μm).
- Important clinical applications such as dermatology, ophthalmology, small parts imaging, oncology diagnosis and monitoring, intravascular ultrasound and dentistry.
- The development of miniaturised transducer arrays is critical to the successful adoption of HFUS systems.
- For example, a 50 MHz linear array specification:
 - Imaging wavelength: 30 μm,
 - Element pitch: 30 µm
 - Piezoelectric composite substrate thickness: 40 μm.
- Advances in fabrication techniques are needed.









A New Fabrication Concept

- New scalable and mask-based approach to device fabrication suitable for high frequency US arrays.
- Micromoulding for fine-scale 1-3 piezoelectric composites.
- Photolithographic definition of array elements on the composite substrates.
- High density interconnect and packaging solutions.
- Design approaches and fabrication processes that have the potential to produce arrays operating up to 100 MHz.
- Quantity scale-up via wafer-based routes leading to cost effective transducers.









Composite Fabrication

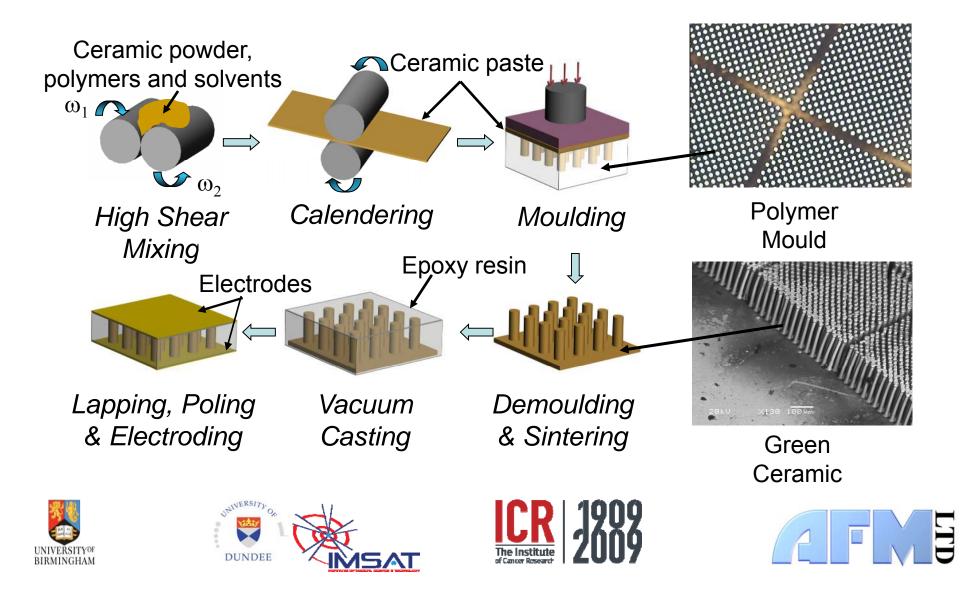




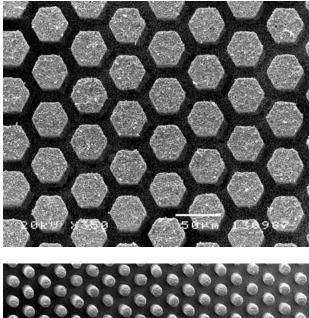


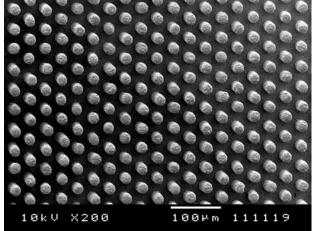


Fabrication of high frequency composites Viscous Polymer Processing - VPP



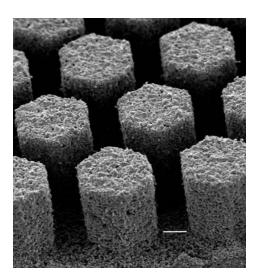
Micropillar Structures fabricated by VPP

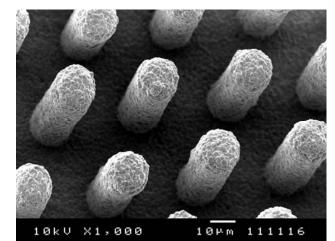








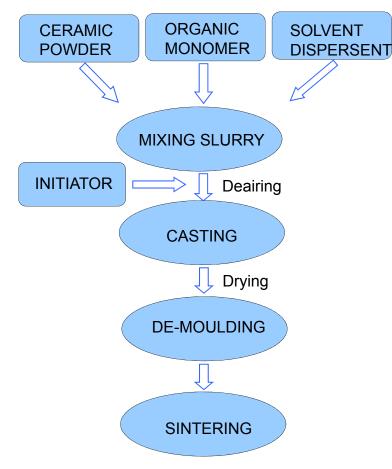








Alternative Fabrication Technique Gel casting

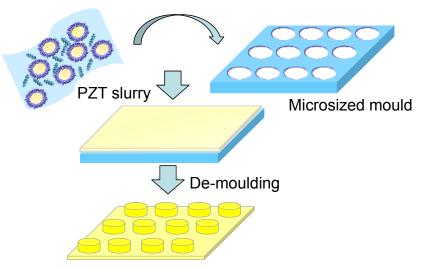


Flow chart of gel casting process.





- •Capability of producing complex parts
- •Homogeneous material properties
- •Rapid forming circle
- •Low capital equipment cost.

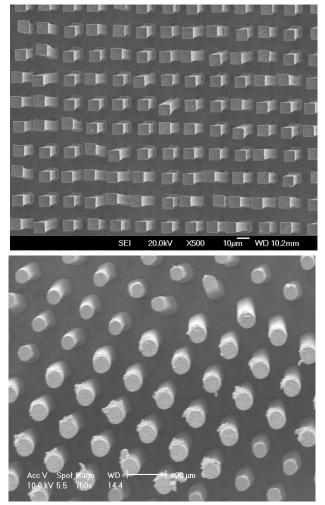


Gel casting for 1-3 piezocomposite fabrication.



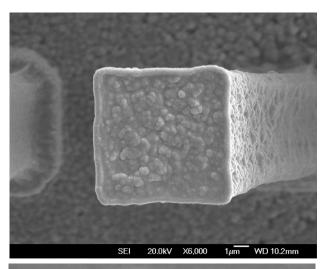


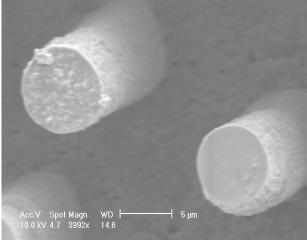
Micropillar Structures fabricated by Gel casting







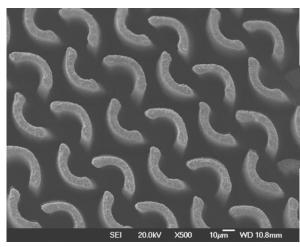


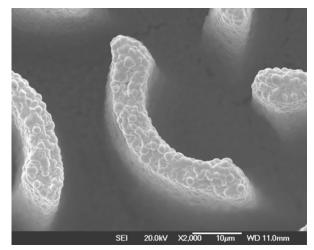


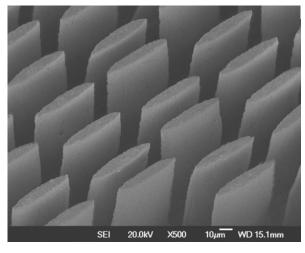




Other pillar shapes and configurations – Gel casting









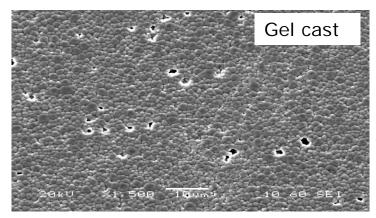


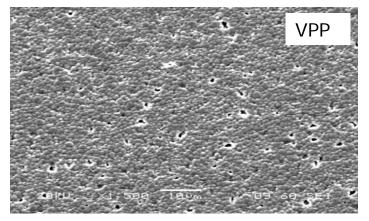




Gel casting Vs VPP

Comparison of microstructure and properties of sintered bulk ceramics (TRS610C)





Sample	Density (g/cm ³)	d ₃₃ (pC/N)	k _t	Permitivity	Dielectric loss
Gel casting	7.70 ± 0.02	632 ± 9.3	0.56 ± 0.001	3200	0.019
VPP	7.65 ± 0.05	586 ± 10.5	0.52 ± 0.002	3040	0.018









Piezocomposite Material Characterisation

- Material parameters determined by fitting electrical impedance to model
- Representative results for high frequency composite:

Resonant frequency: 30 MHz

Ceramic volume fraction: 50 %

$$k_T = 0.51$$

 $d_{33} = 130 \text{ pm/V}$
 $Z_A = 17 \text{ MRayl}$
 $\epsilon_D^S = 460$

 Parameters indicative of significant potential for biomedical imaging





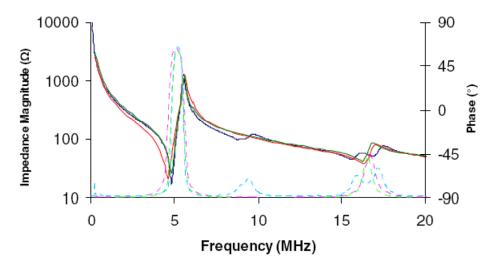


Figure 1. Measured, theoretical, and fitted electrical impedance magnitude and phase for a reference composite operating at a frequency around 5 MHz. Impedance magnitude: Measured — Theoretical — Fitted — Impedance phase: Measured — Theoretical - - Fitted - -

D. MacLennan, et al., "Fundamental performance characterisation of high frequency piezocomposites made with net-shape viscous polymer processing for medical ultrasound transducers," in *Proceedings 2008 IEEE Ultrasonics* Symposium, pp. 58-61, 2008.





Single Element Transducers









30MHz single element transducers

- Transducer: piezoelectric composite, 1.6 mm diameter, 3 mm geometric focus
- Piezoelectric composite:
 - 20 µm diameter pillars
 - 29 µm pitch, hexagonal packing
 - lapped to 54 µm thick
- Packaged and backed with tungsten-loaded epoxy



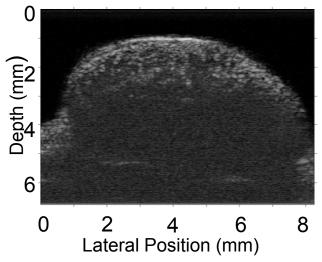


Image of mouse subcutaneous tumour xenograft acquired by mechanically scanning transducer across specimen









Process Improvements for transducer arrays



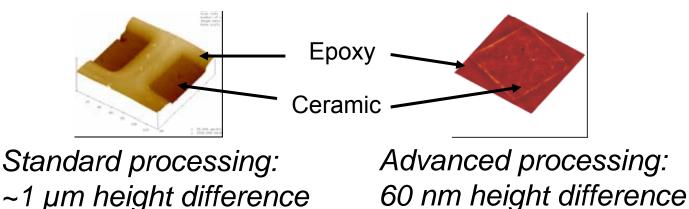






Advanced surface finishing

- Surfaces of composite must be flat, parallel and smooth in preparation for photolithography
- After standard processing, the two dissimilar materials in the composite retain surface relief
- Lapping and polishing processes have been adapted to provide flat and smooth surfaces





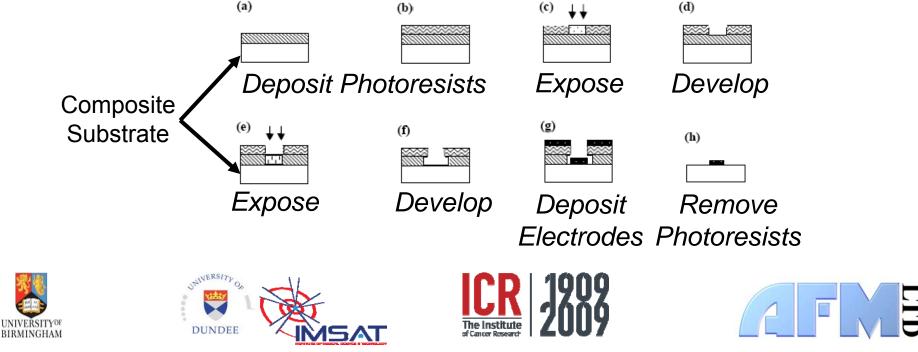






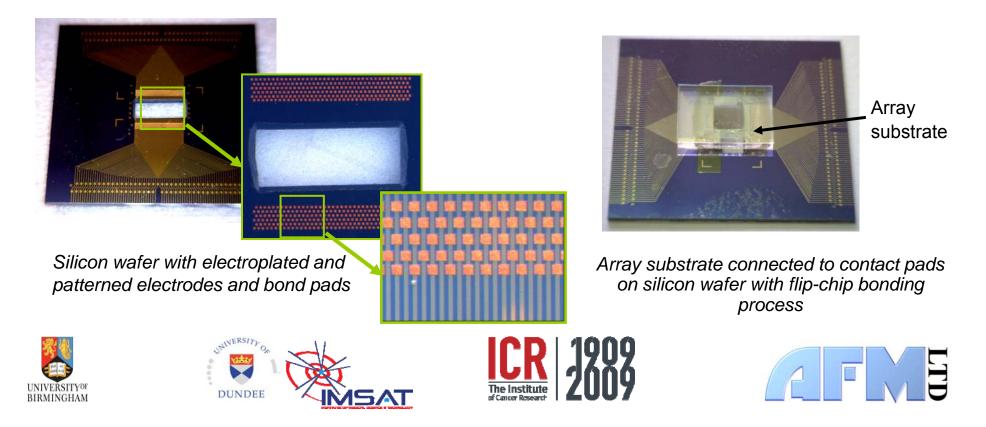
Electrode Patterning

- Lift-off photolithography process adapted for patterning electrodes on composite material
- Solvent-resistant epoxy used for composite fill
- Excellent edge definition and adhesion have been obtained



Mask-based Interconnect

- Standard wirebonding of array element electrodes to flex-circuits does not scale well for arrays above 50 MHz.
- Silicon wafer interconnect solution enables wafer scale production and can be used as a platform for further electronics integration.



Transducer Arrays





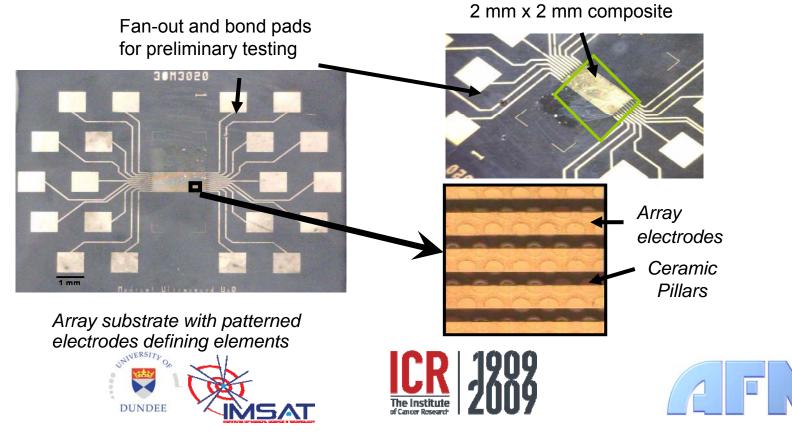




30MHz linear arrays

- Arrays: 20 and 32 element designs, 30 µm wide, 50 µm pitch
- Piezoelectric composite: 20 µm diameter pillars, 29 µm pitch, hexagonal packing, lapped to 55 µm thick
- Wired, packaged and backed with unloaded epoxy for preliminary testing

BIRMINGHAM



30MHz linear arrays



Packaged Prototype Array

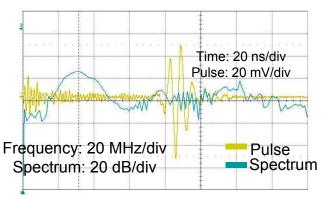
Synthetic aperture Image of 1 mm cylindrical cyst phantom in scattering background. Synthesised aperture: 4 mm, pitch: 10 µm.



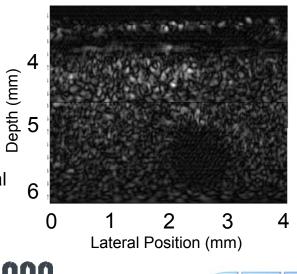






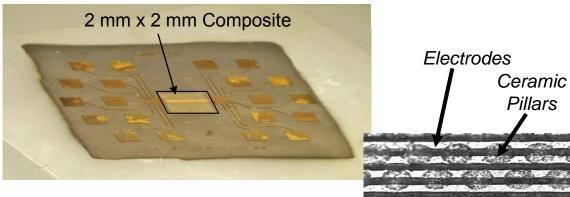


Pulse-echo response of single element from quartz flat Centre Frequency: 31 MHz, Bandwidth: 50 %



100MHz linear array pattern **Proof of Concept**

- Array: 20 elements, ٠ 7.5 µm wide, 15 µm pitch
- Piezoelectric • composite: 40 µm thick (for 50MHz operation)
- Wired, packaged and ٠ backed with unloaded epoxy for preliminary testing



Composite substrate with patterned array electrodes

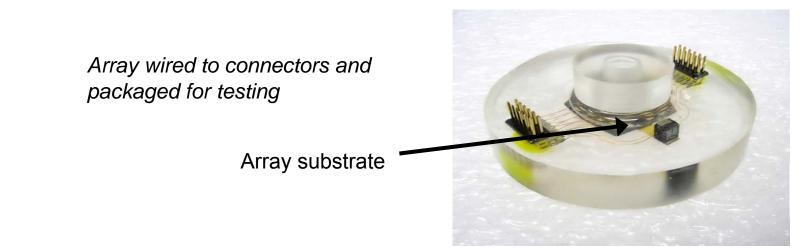








100MHz linear array pattern





Pulse-echo response of single element from quartz flat. Centre Frequency: 51 MHz, Bandwidth: 25 %



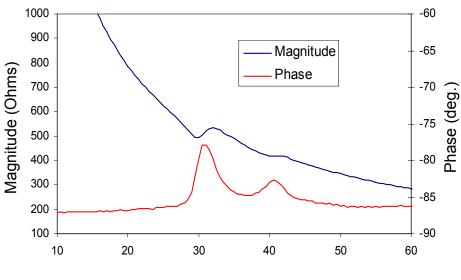






Electrical Impedance

Electrical Impedance of representative element in 30 MHz array



Frequency (MHz)

30 MHz array

- Thickness mode frequency at 30 MHz
 - Lateral mode at 40 MHz due to unoptimised composite
- Elements across array have uniform performance
 - Response consistent with expected performance

100 MHz array

- Elements show piezoelectric response
 - 45 MHz thickness mode
 - Response is highly damped because array pattern very small relative to composite









Potential Applications

Applications for 30 – 100 MHz arrays can be found in the many clinical disciplines which require:

- High spatial resolution
- Real-time imaging
- Example: Dermatology
 - High frequency arrays can be used to enhance 3D and reflex transmission imaging (RTI) by varying the focus through the depth of the tissue in real time
 - RTI measures the attenuation of tissue at the focus of a strongly focused transducer
 - RTI with high frequency arrays has potential for improving the accuracy and efficiency of diagnosis of melanoma
- Example: Ultrasonic and optoacoustic scanning of vasculature
 - The synthetic focusing possible with arrays is required for optoacoustic imaging of oxygenated and deoxygenated blood
 - With high frequency arrays, accurate imaging of microvasculature becomes possible, leading to improved diagnosis and monitoring of many diseases









Summary

- Micromoulding and microfabrication processes have been developed for fabricating fine-scale, HFUS transducer arrays.
- Micromoulded piezoelectric composites with material properties suitable for high frequency imaging have been made.
- Surface finishing and photolithography techniques have been developed and adapted to pattern fine-scale arrays directly on composite surfaces.
- Prototype arrays have been fabricated and perform as expected.









Commercial Prospects

- HFUS is already here!
 - VisualSonics, SonoSite
- Interest in HF from most major Ultrasound players
- Specific applications for HF single element devices
- Cost effective fabrication for HF Arrays (>15 MHz) required
- Wide range of potential applications









Future Work

- Optimise piezoelectric composite and array designs for improved performance at 50 MHz and above.
- Further develop technologies for interconnect between arrays and silicon wafers.
- Integration of HFUS arrays with electronics to minimise cable issues
 - preliminary demonstration of combining a HFUS transducer with an ASIC in collaboration with Penn State

(Bernassau et al, IEEE Ultrasonics Symp, Rome 2009).

• Application specific programmes.







